



AF JFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q77321

Hiroshi OKUMURA

Appln. No.: 10/773,333

Group Art Unit: 3663

Confirmation No.: 8920

Examiner: Johannes P. MONDT

Filed: February 9, 2004

For: THIN FILM TRANSISTOR SUBSTRATE AND METHOD OF MANUFACTURING
THE SAME

AMENDMENT UNDER 37 C.F.R. § 1.116

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 13, 2007, please amend the above-
identified application as follows on the accompanying pages.

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